

ATTORNEY DOCKET NO. 0099/014001

Applicant: Satoshi MORIYA Art Unit: 2833
Application No.: 10/538,744 Examiner: Lee, K. S.
Title: RESISTIVE MATERIAL, RESISTIVE ELEMENT, RESISTOR AND
METHOD FOR MANUFACTURING RESISTOR
International Application No.: PCT/JP2003/016013
International Filing Date : December 15, 2003
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 18, 2009,
please amend the application as follows:

Remarks begin on page 2 of this paper.